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APPLICANTS

Byoung Hee Cho, Ichon-Shi, KOREA, REPUBLIC OF;

** CONTINUING DATA *****

None

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2003-713 01/07/2003 *P*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verifier and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 1
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ADDRESS

04743
 MARSHALL, GERSTEIN & BORUN LLP
 6300 SEARS TOWER
 233 S. WACKER DRIVE
 CHICAGO, IL
 60606

TITLE

Method for forming gate oxide in semiconductor device

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